

Search Notes

Application/Control No.

10/802,053

Examiner

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Applicant(s)/Patent under
Reexamination

CHA, CHI-HO

Art Unit

2611

SEARCHED

Class	Subclass	Date	Examiner
375	260	7/7/2007	JP
	368	7/7/2007	JP
	369	7/7/2007	JP
	147-153	7/7/2007	JP

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
375	260	7/7/2007	JP

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East USPAT/USPGPUB	7/7/2007	JP
Inventor Name Search EAST/EDAN	7/7/2007	JP